

Application/Control No.	Applicant(s)/Patent under Reexamination		
10/529,854	TANAKA, KOJIRO	RO	
Examiner	Art Unit		
RIN SHEN	1657		

	SEAR	CHED	
Class	Subclass	Date	Examiner

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		

SEARCH (INCLUDING SEA	H NOTES ARCH STRATEG	Y)
	DATE	EXMR
updated search.	4/2/2008	BS